L Number	Hits	Search Text	DB	Time stamp
49	12	(micro near hinge) same (micro near machin\$3 or "MEMS")	USPAT;	2004/01/22 17:28
49		(more mean mige)	US-PGPUB;	
			EPO; JPO;	
			DERWENT;	
			IBM_TDB	0004/04/00 40:00
50	27	silicon same (hinge same (three near dimensional) or ("3 near	USPAT;	2004/01/22 18:20
	į	D"))	US-PGPUB;	
		<i>"</i>	EPO; JPO;	
		· ·	DERWENT;	
	İ		IBM_TDB	0004/04/00 40:04
51	24	lin-chuang-chia.in.	USPAT;	2004/01/22 18:21
			US-PGRUB;	
			EPO; JPO;	
			DERWENT;	
			IBM_TDB	2004/01/22 18:21
52	12	lin-chuang-chia.in. and hinge	USPAT;	2004/01/22 10.21
		•	US-PGPUB;	
		i e	EPO; JPO;	
			DERWENT;	
_			IBM_TDB	2003/09/07 12:46
-	0	((open\$3 or groove or hole) same silicon) same (hinge same	USPAT;	2003/03/07 12.40
		(three near dimensional))	US-PGPUB; EPO; JPO;	
	ĺ	*		
			DERWENT;	
			IBM_TDB	2004/01/22 18:10
· ·,	1	((single near crystal) near3 silicon) same (hinge same (three	USPAT;	2004/01/22 10:10
		near dimensional))	US-PGPUB;	
			EPO; JPO; DERWENT;	
			1	
		0 77 A A A A A A A A A A A A A A A A A A	IBM_TDB USPAT;	2003/09/07 12:48
F. Y.	6809	((single near crystal) near3 silicon) same etch\$3	US-PGPUB;	2003/03/01 12:40
	*		EPO; JPO;	
			DERWENT;	
		·	IBM TDB	
	182	(((single near crystal) near3 silicon) same etch\$3) same (micro near machin\$3 or "MEMS")	USPAT;	2003/09/07 12:49
- (***			US-PGPUB;	2000/00/01 12:10
			EPO; JPO;	*
			DERWENT;	
			IBM_TDB	
		www.t.thananananananananananananananananananan	USPAT;	2004/01/22 17:20
-	61	((((single near crystal) near3 silicon) same etch\$3) same	US-PGPUB;	
		(micro near machin\$3 or "MEMS")) and @pd<20020107	EPO; JPO;	
\ \ \ \ \ \			DERWENT;	
			IBM_TDB	
	_	((((circle approximatel) = cor2 cilicon) como etch(2) como	USPAT;	2003/09/07 13:07
-	0	((((((single near crystal) near3 silicon) same etch\$3) same (micro near machin\$3 or "MEMS")) and @pd<20020107) and	US-PGPUB;	
1		(micro near machinas or ivicivis )) and (controlling page capes)	EPO; JPO;	
		(polysilicon near5 cap\$3)	DERWENT;	
			IBM_TDB	
	_	(((((single near crystal) near3 silicon) same etch\$3) same	USPAT;	2003/09/07 13:07
-	0	((((((single near crystal) nears slitcor) same etc.) same (((((single near crystal) nears slitcor) same etc.) and (micro near machin\$3 or "MEMS")) and (micro near machin\$3 or "MEMS") and (micro near machin\$3 or "ME	US-PGPUB;	
ļ.:		(micro near machinas or ivicivis )) and wpd-20020107) and	EPO; JPO;	
1		(polysilicon same cap\$3)	DERWENT;	
	1		IBM_TDB	
	1	(((((single near crystal) near3 silicon) same etch\$3) same	USPAT;	2003/09/07 13:08
1 -	24	(((((single hear crystal) hears slitcor) same etchips) same ((((single hear crystal) hears slitcor) same etchips) same (micro near machin\$3 or "MEMS")) and @pd<20020107) and	US-PGPUB;	
			EPO; JPO;	3 4 4 4 4 4 4 4 4 4 4 4 4 4 4 4 4 4 4 4
		(polysilicon same etch\$3)	DERWENT;	
			IBM_TDB	
	_	(iora near hings) olm	USPAT;	2003/09/11 17:3
] -	7	(micro near hinge).clm.	US-PGPUB	2000
1	457561	annor olm	USPAT;	2003/09/11 17:3
-	157531	sensor.clm.	US-PGPUB	
	400	("MEMS" same conser) clm	USPAT;	2003/09/11 17:3
-	108	("MEMS" same sensor).clm.	US-PGPUB	